



TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
00750425AA

In Re Application Of: H. Park, et al.

Serial No.

Filing Date

Confirmation No.

Examiner

Art Unit

09/924,318

08/08/01

Unassigned

1765

Invention: **METHOD OF BUILDING A CMOS STRUCTURE ON THIN SOI WITH SOURCE/DRAIN ELECTRODES FORMED BY IN SITU**

Address to:

Assistant Commissioner for Patents
Washington, D.C. 20231

RECEIVED
APR 8 2003
TC 1700

Transmitted herewith are:

4 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

Signature

Michael E. Whitham

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30743

PATENT TRADEMARK OFFICE

Dated: April 4, 2003

I certify that this document and attached formal drawings are being deposited on April 8, 2003 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

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